

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	09/992,354	CHEN ET AL.
	Examiner	Art Unit
	Wen-Tai Lin	2154

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
709	224 238	{	
709	242	6/1/05	CWPL
370	351-352 392		